



AF/280
PATENT
#9 201
M. Brunson
2/25/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Rickard M. VON WURTEMBERG et al.

Application No. 09/438,955

Group Art Unit: 2881

Filed: November 12, 1999

Examiner: Cornelius Jackson

For: BOTTOM EMITTING VCSEL (VERTICAL CAVITY SURFACE EMITTING LASER) WITH MONITOR EMISSION THROUGH TOP MIRROR

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

BOX AF
Commissioner for Patents
Washington, D.C. 20231

Sir:

The applicant herewith petitions the Commissioner to extend the time for reply to the Office Action dated October 1, 2001 for

one month from January 1, 2002 to **February 1, 2002.**

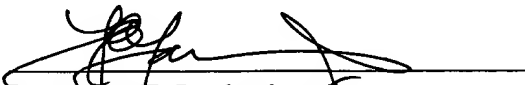
Submitted herewith is a check for \$110 to cover the cost of the extension.

The Patent and Trademark Office is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 501936. This petition is filed in duplicate.

A responsive paper is filed herewith.

Respectfully submitted,

January 23, 2001


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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: BOX AF, Commissioner for Patents, Washington, D.C. 20231 on January 23, 2002.

Geri Spicknall

Signature

